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Model Predictive Control for Process Flow Application using LabVIEW

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ABSTRACT: This paper proposes a comparative study of a Proportional - Integral - Derivative (PID) control scheme and a Model Predictive Control (MPC) strategy for flow control applications. When the control system encounters nonlinearity, the conventional PID control exhibits oscillations. Hence, MPC has proven to be a better and advanced process control in case of dynamic system. In this paper, an MPC control loop for water flow control is proposed with the control algorithm being implemented on a hardware setup for analysis that is interfaced with LabVIEW via Arduino Nano. The behaviour of MPC is demonstrated to be superior to PID controller based on step response and an evaluation of a set of performance parameters like Integral Square Error (ISE), Integral Absolute Error (IAE), settling time, rise time, percentage of peak overshoot.

KEYWORDS: flow control, PID, MPC, LabVIEW, IAE, ISE, Settling Time, Rise time, percentage of peak overshoot.

I. INTRODUCTION

Proportional-Integral-Derivative (PID) controllers are control loops widely used in the process control industry, for the ease with which the plant output can be modulated. Although, PID controller is meant to balance all three-gain parameters that affect the entire setup and may change the characteristics of transient response such as oscillations, overshoot, and settling time. If the system parameters cannot be precisely estimated and attained, the designed PID gains cannot withstand the unpredictable changes and disturbances, and hence exhibits low robustness.

Presence of a constraint in the process causes instability, which can be regulated with ease by the Model Predictive Controller (MPC) and it is being used in many process industries. MPC has the ability to manage constraints and changes in system parameters and hence, it is best suited for large, multivariable processes. The operation of MPC is compared with conventional PID controller and its robustness is explored.

Rosli et al. have proposed a real-time implementation of model predictive control (MPC) for a dynamic system, using MATLAB/Simulink toolboxes, for flow process applications. The pilot plant is interfaced via DAQ data acquisition card and its performance is compared with traditional PID controller, based on step response and their robustness in presence of disturbance [1]. Ang Li has carried out simulations to demonstrate comparison between Model Predictive Control and PID control for water-level maintenance in a two-tank System [2]. Camacho et al. have explained the working principle and control scheme of MPC [3]. More detailed information about the general implementation of Model Predictive Controller is given in [4].

The block diagram of PID and MPC control schemes are as shown in Figure 1. There are 2 forms of MPC: state space model and Hovorka model [5]. In the proposed work, state space model of MPC is used and is characterized by the following strategy [3]:

1) In MPC, the future outputs, for a defined horizon *N* referred to as prediction horizon, are predicted using the process model at each instant *t*. These predicted outputs y(t + k / t) 1 for k = 1...N depend on the known values up to instant 't'



(An ISO 3297: 2007 Certified Organization)

Vol. 5, Issue 8, August 2016

(*i.e.*: past inputs and outputs) and also on the future control signals u(t+k | t), k = 0. . (N-1), are sent to the system for further calculation.

2) By optimizing a determined criterion, the set of future control signals is computed to ensure that the process follows the reference trajectory w(t + k) i.e., the set point.



Fig. 1: Basic block diagram of (a) PID and (b) MPC.

3) The control signal u(t / t) is sent to the process while previously calculated control signals are rejected, as the next sampling instant y(t + 1) is already well known and first step is repeated with this new value and all the sequences are updated. Thus the u(t + 1 / t + 1) is using the receding horizon concept [6] [7]. In order to implement this MPC strategy, the basic structure shown in Figure 1. (b) is used.

Water Water Pump Tank

II. SYSTEM SETUP AND PROCESS MODELLING

Fig. 2: System setup

The system hardware setup for flow control application, shown in Figure 2, includes a pump, flow sensor, Arduino Nano for data acquisition (DAQ) between the process and the computer. Software toolkit includes LabVIEW, PID and MPC toolkit [8], and 'LabVIEW MakerHub LINX' which is an open source add-on for LabVIEW VIs for interacting with common embedded platforms like Arduino.

Specifications of the pump and flow sensor is as follows:

Pump: 12/24V submersible BLDC motor, flow range: 2ltr/min to 20ltr/min, PWM change from 5 to 100% or a control voltage of 0-5V.

Flow sensor: Model: YF-S201, Working Voltage: 5 to 18V DC, Working Flow Rate: 1 to 30 ltr/min, Flow rate pulse characteristics: Frequency (Hz) = 7.5 * Flow rate (ltr/min), Pulses per Liter: 450.



(An ISO 3297: 2007 Certified Organization)

Vol. 5, Issue 8, August 2016

The process flow is modelled in LabVIEW as shown in Figure 3 and hence, the process curve for system identification is generated as shown in Figure 4. The resulting data is used to determine the major characteristics of a flow i.e., the time delay (τ) and the gain (k).



Fig. 4: Process curve for system identification.

Process flow is modelled as a transfer function of time delay, and is expressed to first order as follows:

Transfer function G(s) =
$$k e^{-\tau s} = 0.13 e^{-0.6s} = \frac{0.13}{s+0.6}$$
(3)

III. DESIGN OF PID & MPC IN LABVIEW

Using the LabVIEW Control Design and Simulation toolkit, the PID control scheme [9] and MPC control scheme [10] are built and the block diagrams are shown in Figure 5, Figure 6 respectively.

PID Control Scheme: The interface between LabVIEW and Arduino Nano DAQ is initialized using Linx with DAQ being initialised as an I/O device. The PID controller is tuned so that process variable follows the defined set point. The PWM duty cycle percentage is varied to control the speed of the pump via an analog output to DAQ, which is the manipulated variable.

MPC Control Scheme: Initialization through Linx is performed as in PID control, and transfer function of process flow obtained in Section II is converted into state-space model and fed to 'Create MPC Controller.vi'. The control parameters and cost weights of MPC are defined in 'Set MPC controller.vi' and then MPC controller is implemented. In optimizer, integral action takes place predicting the future outputs, resulting in control action u(k) to ensure that process variable (flow) follows the defined set point resulting in desired output.



(An ISO 3297: 2007 Certified Organization)

Vol. 5, Issue 8, August 2016



Fig. 5: Block diagram of PID control scheme



Fig. 6: Block diagram of MPC control scheme.

The PID and MPC process model VI's use the following common sub VI's, as shown in Figure 7(a) and Figure 7(b):

Flow Input VI: This subVI is used to measure the flow rate in terms of frequency which is scaled to display litre/minute.

PWM Output VI: This subVI gives the PWM duty cycle in percentage and thus an equivalent analog output to DAQ.



(An ISO 3297: 2007 Certified Organization)

Vol. 5, Issue 8, August 2016



Fig. 7: SubVI's: (a) Flow Input VI and (b) PWM Output VI.

IV. RESULT AND COMPARISON

In this study, the tuning parameters of PID controller like the gain (K), the integral constant (I) and the derivative constant (D), are determined iteratively with the Ziegler Nichols method [10]. Tuned values are found out to be: Kc =0.6, T_i = 0.008 min and T_d = 0 min.



Fig. 8: Transient response: (a) PID output and (b) MPC output

The Figure 8 presents the set point tracking results of PID and MPC schemes. IAE and ISE for both the controllers are calculated [12] for step change from 3 cm to 7 cm in steps of 1 cm and the values are tabulated in Table 1.

Table 1: TAE and ISE of PID and MPC						
Step	IAE		ISE			
change	PID	MPC	PID	MPC		
3-4	6.8029	4.1397	4.0227	2.2113		
4-5	6.4375	4.6404	3.6602	2.5341		
5-6	8.3010	5.4674	4.6382	2.5422		
6-7	8.8032	5.8211	4.8612	2.7435		

From Table 1, it follows that the error analysis shows that IAE and ISE of MPC are better than that of PID. Hence, process system with MPC shows smaller error and less sustained oscillations over time.



(An ISO 3297: 2007 Certified Organization)

Vol. 5, Issue 8, August 2016

Settling time, peak time, rise time, percentage overshoot of PID and MPC can be analysed from the transient response shown in Figure 6 for a step change from 4 cm to 5 cm.

Response parameter	PID	MPC
Peak Time (in seconds)	31.8	20.8
Settling time 3% error band(in seconds)	27.4	18.6
Rise Time (in seconds)	9.2	6.8
Percentage Overshoot	4.2	3.5

Table 2: Transient response for PID and MPC control scheme

Table 2 infers that MPC shows better transient response than PID in terms of all transient response parameters. The rise time for a change of 10- 90 %, MPC shows a lesser value which indicates that it is faster than PID controller. MPC shows less percentage of peak overshoot than PID controller. The low ISE for MPC shows it is a better choice than PID control in removing large steady state errors.

V. CONCLUSION

A comparative study of a Proportional-Integral-Derivative (PID) control scheme and a Model Predictive Control (MPC) strategy for flow control applications is presented as depicted in Figure 5 and Figure 6. MPC control loop for water flow control is proposed with the control algorithm implemented on a hardware setup for analysis and is interfaced with LabVIEW via Arduino Nano DAQ.

Table-1 demonstrates the performance of MPC is superior to PID controller based on step response and its parameters like Integral Square Error (ISE), Integral Absolute Error (IAE), settling time, rise time, percentage of peak overshoot. Table-2 shows the MPC controller is faster in terms of rise time, settling time and exhibits less percentage overshoot and less sustained oscillations. Hence, MPC is the choice of the control designer in applications demanding smaller value of spike in process variable.

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